

## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

### Title of Invention

CHEMICAL TREATMENT TO RETARD DIFFUSION IN A  
SEMICONDUCTOR OVERLAYER

Application Number :

Confirmation Number:

First Named Applicant: Kevin Chan

Attorney Docket Number: FIS920040027

Art Unit:

Examiner:

Search string: ( 5731626 or 5967794 or 6043139 or 6271551 ).pn

### US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5731626	1998-03-24	Eaglesham et al.			
	2	5967794	1999-10-19	Kodama			
	3	6043139	2000-03-28	Eaglesham et al.			
	4	6271551	2001-08-07	Schmitz et al.			

### Signature

Examiner Name	Date